



LIST OF REFERENCES CITED BY APPLICANT

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Group Art: ~~3713~~ 3714

Applicant: Tapio HAMEEN-ANTTILA et al.

U.S. PATENT DOCUMENTS

*Ex. Intls.		Document No.	Date	Name	Class	Subclass	Filing Date
<i>Ch</i>	AA	5,283,733	02/1994	Colley	364	411	03/1992
<i>Ch</i>	AB	5,544,321	8/1996	Theimer et al.	395	200.11	06/1995
<i>Ch</i>	AC	5,949,679	09/1999	Born et al.	364	410.1	07/1996
<i>Ch</i>	AD	5,434,789	07/1995	Fraker et al	364	460	10/1993
<i>Ch</i>	AE	5,809,415	09/1998	Rossmann	455	422	12/1995

FOREIGN PATENT DOCUMENTS

*Ex. Intls.		Document No.	Date	Country	Name	Class	Subclass	Translation Yes/No
<i>Ch</i>	AF	WO 99/47216	09/1999	PCT	Fendis	A63B	71/06	Yes
<i>Ch</i>	AG	WO 00/76599 A1	12/2000	PCT	Ogawa	A63B	71/06	Yes
<i>Ch</i>	AH	WO 99/37369	07/1999	PCT		A63B	71/06	Yes, See JP 11-206944 and 11-206945
<i>Ch</i>	AI	JP 11-206944	08/1999	Japan	Yoshikatsu	A63B	71/06	Yes
<i>Ch</i>	AJ	JP 11-206945	08/1999	Japan	Yoshikatsu	A63B	71/06	Yes
<i>Ch</i>	AK	EP 0 674 924 A1	10/1995	EPO	Narduzzo et al.	A63B	71/06	Yes
<i>Ch</i>	AL	EP 0 820 183 A2	01/1998	EPO	Matsumoto et al.	H04M	7/22	Yes

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AM		
	AN		
	AO		

RECEIVED

OCT 22 2002

EXAMINER: *C. White*

DATE CONSIDERED: *3/20/03*

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